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PROSECUTION OF THE SUBJECT APPLICATION

Applicants: L.W. Graham et al. Attorney Docket No.: SEMT116060
Application No.: 09/429,446 Group Art Unit: 1734
Filed: October 28, 1999 Examiner: W. Leader
Title: METHOD, CHEMISTRY, AND APPARATUS FOR NOBLE METAL
ELECTROPLATING ON A MICROELECTRONIC WORKPIECE

U.S. PATENT DOCUMENTS

*Examiner Initial	ID	Document No.	Date	Name
<u>WL</u>	U1	4,285,784	08/1981	Flinn et al.
<u>WL</u>	U2	4,358,352	11/1982	Rhoda
<u>WL</u>	U3	4,427,502	01/1984	Abys
<u>WL</u>	U4	4,750,977	06/1988	Marrese
<u>WL</u>	U5	5,310,475	05/1994	Kitada et al.
<u>WL</u>	U6	5,421,991	06/1995	Yarita
<u>WL</u>	U7	5,494,560	02/1996	Arimoto et al.
<u>WL</u>	U8	5,529,680	06/1996	Kitada et al.
<u>WL</u>	U9	5,620,583	04/1997	Kuhn et al.

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William Leader

3/2001

*Examiner: Initial if reference considered, whether or not citation is in conformance with M.P.E.P. § 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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